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Our Ref. No.: 42390.P4514 D
Express Mail No. EM560643726US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application for:)
Doyle)
For: METHOD FOR DELAMINATING)
A THIN FILM USING)
NON-THERMAL TECHNIQUES)

PRELIMINARY AMENDMENT

Honorable Commissioner of Patents
and Trademarks
Washington, D.C. 20231

Sir:

Please amend the above-identified divisional application as follows:

IN THE SPECIFICATION

After the title, please insert --This is a divisional of Serial
Number 09/107,398, filed June 30, 1998.--

IN THE CLAIMS

Please cancel claims 1-13.

Please add the following claims:

--14. An apparatus comprising:
a first substrate with a semiconductor film formed thereon;
and

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1
2
3
[Handwritten initials]